

Electronic Acknowledgement Receipt

EFS ID:	1931515
Application Number:	10723714
International Application Number:	
Confirmation Number:	9797
Title of Invention:	Method for etching high dielectric constant materials and for cleaning deposition chambers for high dielectric constant materials
First Named Inventor/Applicant Name:	Bing Ji
Customer Number:	23543
Filer:	Joseph D. Rossi
Filer Authorized By:	
Attorney Docket Number:	06299P2 USA
Receipt Date:	02-JUL-2007
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Application Type:	Utility

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed	06299P2-usa-07-02-07-info-discl-statement.pdf	1068006	no	4
Warnings:					
Information:					
2	Foreign Reference	06299P2-usa-1-foreign-reference.pdf	923055	no	17
Warnings:					
Information:					
3	Fee Worksheet (PTO-06)	fee-info.pdf	8196	no	2
Warnings:					
Information:					
Total Files Size (in bytes):				1999257	
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